

Time		Thursday, September 26th, 2019				Time
		NEFELI HALL	DELPHI	JUPITER HALL	ATHENA HALL	
08.30						08.30
08.45-09.00	JUPITER HALL	<b>Plenary 7</b> <b>MNE Fellow Award &amp; Lecture</b> Hella-Christin Scheer				08.45-09.00
09.00-09.15						09.00-09.15
09.15-09.30						09.15-09.30
09.30-09.45	JUPITER HALL	<b>Young Investigator Award Invited Lecture</b> Yuksel Temiz				09.30-09.45
09.45-10.00						09.45-10.00
10.00-10.15	JUPITER HALL	<b>Award Ceremony</b>				10.00-10.15
10.15-10.30		<b>Coffee break</b>				10.00-10.15
10.30-10.45						10.15-10.30
10.45-11.00		<b>Session A7: Electron and Ion Beam Lithography</b> A single integrated fiberprobe for optogenetic stimulation and electrical recording of neural activity Spagnolo B.	<b>Session B7: Nanostructures for Photonics</b> Optofluidic waveguide using oil-impregnated nanoporous surfaces as cladding layers Asawa K.	<b>Session C7: Materials &amp; Devices for nanoelectronics</b> Merging Computing and Sensing for Low power and Sustainable Edge Applications Ernst T. CEA-LETI, Grenoble, France	<b>Session D7: Micro &amp; Nano Fluidics</b> 3D coaxial liquid injection and extraction system by 2-photon-polymerization Erfle P.	10.45-11.00
11.00-11.15		Cs and Rb Ion Coldbeam Suitability for Circuit Edit Greenzweig Y.	Fabrication of Vivid, Wide Area Transmission Holograms in Plastic Substrates by Nanoimprint Lithography Morton K.		Fabrication of a $\mu$ -fluidic device by two-photon lithography using a positive tone resist Van der Velden G.	11.00-11.15
11.15-11.30		The Marriage of the Ions and Chemistry to Fulfill Semiconductor devices Preparation Goupil G.	<b>INVITED: Biomimetics of photosynthetic photonic structures. How natural light harvesting could become an inspiration for nanotechnology</b> Lopez, Martin	Vertical field-effect transistors based on 3D GaN nanostructure arrays Stempel K.	A Precise, Low-Power, Electrokinetically Actuated Micropumping Mechanism Eden A.	11.15-11.30
11.30-11.45		Excitation power density dependence of photocurrent from InGaN photocathode Sato D.		Design and simulation of planar nano vacuum channel transistors (pNVCT) Turchetti M.	<b>INVITED: Design and Fabrication of Plastic Nanofluidic Devices for Single Molecule Detection</b> Sunggook Park Louisiana State University, USA	11.30-11.45
11.45-12.00		Nanofabrication and imaging characterization of 30 nm resolution charts with vertical sidewalls Zhu J.	Three dimensional silicon nanostructures for photonic applications Chang B.	Integration of 2D MoS2 with InAlAs/InGaAs heterojunction for dual color detection in both visible and near-infrared band Deng J.		
12.00-12.15		<b>Lunch break</b>				12.00-12.15
12.15-12.30						12.15-12.30
12.30-12.45						12.30-12.45
12.45-13.00						12.45-13.00
13.00-13.15		<b>Session A8: Industrial I</b> The path to Roll to Roll Imprint Technology, an Enabling Technology Maltabes J. Applied Materials, Germany	<b>Session B8: Wetting III</b> A scalable process for manufacturing hierarchical superhydrophobic structures on aluminium: promotion of stable dropwise condensation for tropical air conditioning Kadala K.	<b>Session C8: Materials for Nanoelectronics II</b> Suitability of HSQ as fabrication material for vertical devices at nano-scale Amat E.	<b>Session D8: Devices for DNA studies</b> Ultrafast Phage-Long DNA Size Profiling Using Optonofluidic Device Chou C.	13.00-13.15

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13.15-13.30		Designing Surfaces for Under-Liquid Super-Repellency Zhu P.	Memristive behaviour of electrodeposited thermoelectric materials Mihailovic I.	Nanomechanical DNA resonator for DNA structural alterations studies Marini M.	13.15-13.30
13.30-13.45	Flexpol: Developing a bactericide adhesive film Kehagias N.	Superhydrophobic and superoleophobic properties enhancement on PDMS microstructure using simple flame treatment method Atthi N.	Electrostatically-coupled dopant atom double quantum dot transistor measurements at room-temperature Abualnaja F.	Controlling DNA translocation in nanofluidic devices using topography Fernandez-Cuesta I.	13.30-13.45
13.45-14.00	Full-Scale Manufacturing of 200mm/300mm Wafers on a Fully Integrated Nanoimprint Lithography System Wiesbauer H.	Design, fabrication and characterisation strategies for large area bactericidal polymer films Francone, A.	Sputtered ZnO nanostructure homojunctions fabricated on room temperature pre-patterned substrates Aperathitis E.	Electrokinetic Scanning Probe for Localized Surface Patterning and Analysis Ostromohov N.	13.45-14.00
14.00-14.15	Coffee break				14.00-14.15
14.15-14.30					14.15-14.30
14.30-14.45	<b>Session A9: Industrial II</b> All integrated mix & match direct-write nano- and microlithography platform based on local heat induced sublimation of polyphthaldehyde resist Holzner F.	<b>Session B9: Nanofabrication</b> 58. Materials characterization of gas assisted etch and deposition of focused Cs+ ion beam Dreznera Y.	<b>Session C9: Materials for photonics</b> 338. Tuning Fluorophores Concentration and Their Residence Time in Zero-Mode Waveguides Barbaglia A.	<b>Session D9: Lab &amp; Organ on-chip</b> A Novel Micro Free-Flow Electrophoresis 3D printed Lab on a Chip for exosomes separation Barbaresco F.	14.30-14.45
14.45-15.00	Advanced FIB Patterning Strategies for Photonic Devices Nadzeyka A.	Lithium-Doping of ZnO: is it possible to chemically produce p-type ZnO? Makarona E.	Very High Refractive Index Transition Metal Dichalcogenide Photonic Conformal Coatings by Conversion of ALD Metal Oxides Schwartzberg A.	Loading of biodegradable microcontainers with budesonide for local treatment of inflammatory bowel disease Abid Z.	14.45-15.00
15.00-15.15	New high etch resistant high resolution silsesquioxane based resist for DUV/EUV and ebeam lithography as long shelf-life and more sensitive alternative for HSQ Grüneberger F.	Development of van der Waals force based microscale joint for microscale assembly Jang K.	Fabrication and novel applications of GaN-based microLED arrays Gülink J.	Lensless imaging strategies for micro-particles and bacterial colonies counting Yescas González T.	15.00-15.15
15.15-15.30	Multiscale Position Correction for Automated Device-scale STM Lithography Owen J.	Electrically controlled modification of polymer film structure of semiconductor – insulator composites casted by horizontal-dipping Awskiuka K.	Magnetic Dipole Resonance Induced Visible Luminescence from Hundred Nanometers of Silicon Particles Chang S.	3D structuration of porous PDMS by emulsion templating for the fabrication of cell culture scaffolds Riesco R.	15.15-15.30
15.30-15.45	Short Break				15.30-15.45
15.45-16.00	<b>Session A10: Resists</b> Evaluation of RE-650 as a positive tone resist for electron beam lithography with high plasma etch durability Zhu M.	<b>Session B10: Microfabrication</b> Manufacturing of local defined nano- and microstructures for semiconductor devices by dewetting phenomena Ernst O.	<b>Session C10: Miscellaneous</b> Highly sensitive and selective NO2 gas sensor using patterned FTO electrodes Kim Y.	<b>Session D10: Chem. Sensors &amp; Biosensors II</b> Engineering light collection volumes with microstructured tapered optical fibers for optical readout of neural activity monitoring Maglie E.	15.45-16.00

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16.00-16.15	Environmentally friendly nanofabrication with cellulose and water Johann Osmond J.	Templated dewetting of ultra-long wires for a Si-based circuit Bollani M.	Single-Mode Polymer Ridge Waveguide Integration of Organic Thin-Film Laser Čehovski M.	Electrochemical Sensing Based on Inkjet-Printed Reduced Graphene Oxide on a Flexible Substrate Choi J.	16.00-16.15
16.15-16.30	In-situ monitoring of development step of high-resolution e-beam resists Mpatzaka T.	Deposition and optimization of Schottky junctions by Atomic Layer Deposition for piezotronic strain sensors Joly R.	A MEMS based capacitive resonator designed for the detection of the target analyte Tez S.	Microelectrode Arrays with Integrated Pneumatic Cavities for Electrode Position Control in Retinal Prosthesis Xu Y.	16.15-16.30
16.30-16.45	Synthesis and Photolithographic Characterization of Phenolic Molecular Resists under Electron-beam and Extreme UV Irradiation Lee J.	Patterning Platinum using CMP and plasma etching industrially compatible processes Elshaer A.	Integration of piezoelectric nanostructures with MEMS by inkjet printing Murillo G.	Effects of the Acid-base property of the Dopant on the SnO2 Gas Sensor Yuan Z.	16.30-16.45
16.45-17.00	JUPITER HALL	<b>Plenary 8</b> <b>New Materials and Devices for Interfacing with the Brain</b>			16.45-17.00
17.00-17.15		Malliaras, George			17.00-17.15
17.15-17.30		University of Cambridge, UK			17.15-17.30
17.30-17.45	JUPITER HALL	<b>Announcements &amp; Closing Remarks</b>			17.30-17.45
17.45-18.00					17.45-18.00
18.30					18.30
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19:00					19:00
19:15	<b>Excursion to Lindos</b>				19:15
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